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ONLINE ISSN : 1349-6603 PRINT ISSN : 0387-0200

## The Review of Laser Engineering

Vol. 31 (2003), No. 12 p.829

[Image PDF (1339K)] [References]

## Near-Field Infrared Microspectroscopy for Chemical Imaging

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(Received: July 31, 2003)

**Abstract:** Near-field optical microscopy provides us with super-resolving capability of optical and spectroscopic imaging/sensing by confining photons within a much smaller region than their wavelength. In this article, we review near-field infrared microscopy and spectroscopy for chemical analysis and imaging of materials at nanometric scale. After brief introduction to near-field optics, key elements for realization of near-field IR microscopy are described. Then, we show several experimental results of near-field IR spectroscopy using a several kinds of IR light sources and near-field probes. Possibility for application of FEL to near-field IR spectroscopy is also discussed.

Key Words: <u>Near-Field Optics</u>, <u>NSOM</u>, <u>Infrared Microspectroscopy</u>, <u>FEL</u>, Nanoscience, Nanotechnology

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To cite this article:

Satoshi KAWATA and Yasushi INOUYE: The Review of Laser Engineering, Vol. 31, (2003)

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doi:10.2184/lsj.31.829 JOI JST.JSTAGE/lsj/31.829

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